



PATENT
8097-1003

IN THE U.S. PATENT AND TRADEMARK OFFICE

In re application of

Takahuki SHIMAMUNE et al.

Conf. 2298

Application No. 10/527,801

Group 2892

Filed October 11, 2005

Examiner E. Ullah

PROCESS FOR PRODUCING HIGH-PURITY SILICON
AND APPARATUS

PETITION FOR EXTENSION OF TIME

Assistant Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

September 9, 2008

Sir:

The undersigned hereby petitions for an extension of time to respond to the Official Action of July 9, 2008 for one month to September 9, 2008.

Please charge the extension fee of \$60.00 to our credit card set forth in the attached Credit Card Payment Form.

A responsive paper is filed herewith.

Respectfully submitted,

YOUNG & THOMPSON

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